

Micro-patterning layers by flame spray aerosol deposition

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ABSTRACT

Here we present a CMOS-compatible, two-step method for deposition and *in-situ* mechanical stabilization of gas sensitive, metal-oxide microlayers on wafer-level. Lace-like highly porous, Pt-doped SnO₂ nanostructured layers are deposited at wafer-level on 69 microsensors. Second, these layers are converted in well-adhered, cauliflower-like structures (figure 1b, inset). The resulting sensor layer performance is characterized using the analytes CO and EtOH on microsensor devices.

1 INTRODUCTION

The development of low-cost, portable, metal-oxide gas sensors with high sensitivity, selectivity and material stability bears considerable scientific and commercial potential (Eranna *et al.*, 2004). Highly sensitive nano-material synthesis by direct, aerosol-based methods offer unique advantages in comparison to wet-routes including crack-free, highly pure deposits, and the fact that only few process steps are required (Madler *et al.*, 2006). Sputtering, spray pyrolysis, cluster beam deposition, spray pulverization, combustion chemical vapor deposition (Liu *et al.*, 2005) and, recently, flame spray pyrolysis (FSP) have been applied to yield nanostructured sensing layers. The FSP freshly-deposited layers, in particular, consist of highly-porous (98%), loosely interconnected, soft nanostructures (Madler *et al.*, 2006). These, however, can be easily destroyed under mechanical stress and require stabilization. As we have shown lately it is possible to restructure the morphologies of these layer by *in-situ* annealing reaching higher mechanical stability (Tricoli *et al.*, 2008).

2 RESULTS AND DISCUSSION

Figure 1 shows TEM images of powder samples that were collected on a filter placed downstream of the sensor deposition area from flames A (Fig. 1a, b) and D (Fig. 1c, d). Mostly polyhedral particles are made which are similar to previously FSP-made and vapor-fed, flame-made SnO₂ particles. The number of small particles ($d_{\text{TEM}} < 10$ nm) in the TEM images decreases with increasing FSP flame enthalpy density, in agreement with the decrease in average grain size (SSA) and crystal sizes.

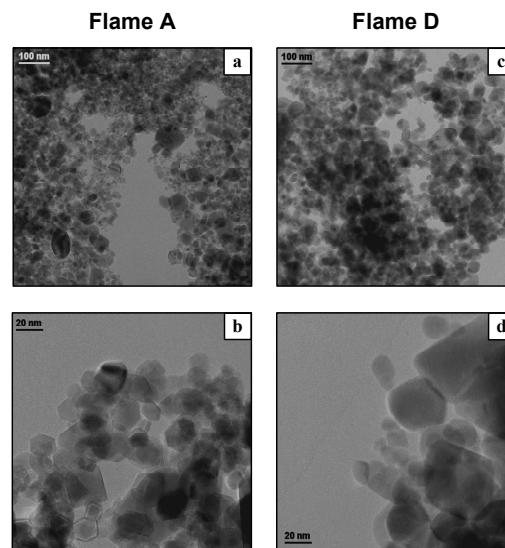


Figure 1: TEM images of SnO₂ particles produced by FSP. The particle size increases with increasing flame enthalpy.

Figure 2 shows the resistance of a sensor with a nanostructured, transparent SnO₂ layer ($d_{\text{XRD}} = 12$ nm) at different ethanol concentrations by heating the substrate at 220 °C. The response of the sensor response was in the range of seconds and a stable resistance was reached promptly. The sensor response to

ethanol was always large in comparison to previous studies.

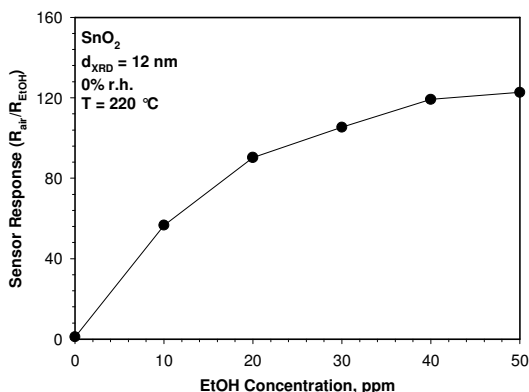


Figure 2: Sensor response to increasing ethanol concentrations.

3 CONCLUSIONS

Uniform, regular, macroporous Pt/SnO₂ layers have been patterned simultaneously on microsensors on wafer-level down to a diameter of 100 μm at 20 μm resolution. Gas microsensors showed a detection limit to CO of 1 ppm and fast response and recovery times. The layers had a large response also to EtOH ranging from 60 to 120 for concentrations varying from 10 to 50 ppm at 220 $^\circ\text{C}$. Recent studies have reduced this to 100 ppb.

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